

Application/Control No.	Applicant(s)/Patent under Reexamination
10/788,615	MUKKER ET AL.
Examiner	Art Unit
Hong C. Kim	2185

	SEARCHED					
Class	Subclass	Date	Examiner			
711	140 167 168 169	2/R/06	4			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST	2/18/06	162		